Notice of References Cited Application/Control No. 10/582,657 Examiner Xiaoliang Chen Applicant(s)/Patent Under Reexamination PEKKARINEN ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-3,843,851 A	10-1974	Harada et al.	200/5E
*	В	US-3,869,637 A	03-1975	Usui, Setsuo	313/500
*	C	US-3,881,921 A	05-1975	Frank, Lee F.	430/53
*	D	US-5,060,595 A	10-1991	Ziv et al.	118/722
*	Е	US-5,105,238 A	04-1992	Nikaido et al.	257/40
*	F	US-5,349,346 A	09-1994	Wu, Shin-Chyuan	340/908
*	G	US-5,461,377 A	10-1995	Oono et al.	341/22
*	Η	US-2001/0049207 A1	12-2001	Sakata et al.	439/66
*	I	US-2002/0113934 A1	08-2002	Aoki, Hironori	349/149
*	J	US-2004/0067015 A1	04-2004	Nakajima, Toshihiro	385/033
*	K	US-7,553,088 B2	06-2009	Nakajima, Toshihiro	385/64
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	Ø					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.